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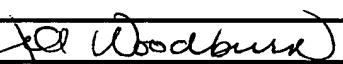
## TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

TRANSMITTAL FORM  (to be used for all correspondence after initial filing)	Application Number	10/601,144	
	Filing Date	6-20-2003	
	First Named Inventor	Bhullar	
	Art Unit	1743	
	Examiner Name		
Total Number of Pages in This Submission	7 + Ref	Attorney Docket Number	BMID 9958 CIP US

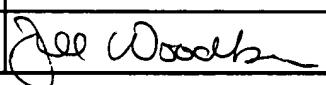
ENCLOSURES (Check all that apply)		
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/ Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation <input type="checkbox"/> Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____	<input type="checkbox"/> After Allowance communication to Technology Center (TC) <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please identify below): <div style="border: 1px solid black; padding: 2px; margin-top: 2px;">115 References Return-Receipt Postcard</div>
Remarks		

### SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm or Individual name	The Law Office of Jill L. Woodburn, LLC Jill L. Woodburn
Signature	
Date	July 2, 2004

### CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.

Typed or printed name	Jill L. Woodburn		
Signature		Date	July 2, 2004

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Docket No. BMID 9958 CIPUS

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Bhullar et al.

Application No.: 10/601,144

Group No.: 1743

Filed: June 20, 2003

Examiner: *To Be Assigned*

For: Method of Making a Biosensor

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

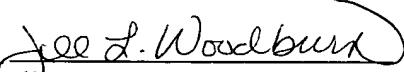
Pursuant to 37 CFR 1.98, the following information is brought to the attention of the U.S. Patent Office.

It is not believed that the disclosure contained in any of the references listed on the attached Form 1449 anticipates Applicant's invention, or that any of the disclosures, alone, or in combination with other disclosures, render Applicant's invention obvious. The Examiner, however, is invited to read each reference in its entirety to ascertain its relevance to the present application and claimed invention. The Examiner is also asked to make each reference of record.

The claims are believed to be in condition for allowance, and allowance of the application is respectfully requested. If necessary, it is requested that all fees due be charged to Deposit Account Number 02-2958 with reference to (BMID 9958 CIP US).

Respectfully submitted,

Date: July 2, 2004

  
Jill L. Woodburn  
Reg. 39,874  
Attorney for Applicant



U.S. Department of Commerce Patent and Trademark Office  INFORMATION DISCLOSURE STATEMENT				ATTY DOCKET NO. BMID 9958 CIP US	SERIAL NO. 10/601,144		
				APPLICANT BHULLAR et al.			
				FILING DATE 06/20/2003	GROUP 1743		
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
1		4,081,653	3-28-1978	Koo et al.	219	121	
2		4,131,484	12-26-78	Caruso, et al.	134	1	
3		4,414,059	11-8-83	Blum et al.	156	659.1	
4		4,684,437	8-4-1987	Donelon et al.	156	643	
5		4,865,873	9-12-1989	Cole et al.	427	53.1	
6		4,874,500	10-17-89	Madou et al.	204	412	
7		4,897,173	1-30-90	Nankai et al.	204	403	
8		5,018,164	5/21/91	Brewer et al.	372	109	
9		5,089,103	2-18-92	Swedberg	204	182.8	
10		5,104,480	4-14-92	Wojnarowski et al.	156	643	
11		5,120,420	6-9-92	Nankai et al.	204	403	
12		5,264,103	11/93	Yoshioka et al.	204	403	
13		5,266,179	11-30-93	Nankai et al.	204	401	
14		5,288,636	2-22-94	Pollmann et al.	435	288	
15		5,334,279	8-2-94	Gregoire	156	630	
16		5,336,388	8-9-94	Leader et al.	204	406	
17		5,382,346	1-17-95	Uenoyama et al.	204	403	
18		5,390,412	2-21-95	Gregoire	29	848	
19		5,391,250	2-21-95	Cheney II et al.	156	268	
20		5,395,504	3-7-95	Saurer et al.	204	403	
21		5,413,690	5-9-95	Kost et al.	204	403	
22		5,414,224	5-9-95	Adasko et al.	174	262	
23		5,426,850	6-27-95	Fukutomi et al.	29	848	
24		5,437,999	5-13-97	Diebold et al.	435	288	
25		5,451,722	9-19-95	Gregoire	174	261	
26		5,465,480	11-14-95	Karl et al.	29	825	
27		5,496,453	3-5-96	Uenoyama et al.	205	777.5	
28		5,508,171	4-16-96	Walling et al.	205	777.5	
29		5,509,410	4-23-96	Hill et al.	128	637	
30		5,512,489	04-1996	Girault et al.	205	777.5	
31		5,575,930	11-19-96	Tietje-Girault et al.	216	65	
32		5,576,073	11-19-96	Kickelhain	427	555	
33		5,589,326	12-31-96	Deng et al.	435	4	
34		5,593,739	1-14-97	Kickelhain	427	555	
35		5,628,890	5-13-97	Carter et al.	204	403	
36		5,635,054	06-1997	Girault et al.	205	775	
37		5,682,884	11-4-97	Hill et al.	128	637	
38		5,708,247	1-13-98	McAleer et al.	204	403	
39		5,755,953	5-26-98	Henning et al.	205	778	
40		5,773,319	6-30-98	Chu et al.	438	39	
41		5,739,039	04-1998	Girault et al.	436	149	
42		5,758,398	6-2-98	Rijnbeek et al	29	25.42	
43		5,759,364	6-2-98	Charlton et al.	204	403	
44		5,762,770	6-9-98	Pritchard et al.	204	403	
45		5,798,031	8-25-98	Charlton et al.	204	403	
46		5,948,289	09-07-99	Noda et al.	219	121.69	
47		5,955,179	9/99	Kickelhain et al.	428	210	
48		5,956,572	9-21-99	Kidoguchi et al.	438	96	
Examiner				Date Considered			

\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609.  
 Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

U.S. Department of Commerce Patent and Trademark Office					ATTY DOCKET NO. BMID 9958 CIP US		SERIAL NO. 10/601,144	
					APPLICANT BHULLAR et al.			
					FILING DATE 06/20/2003		GROUP 1743	
INFORMATION DISCLOSURE STATEMENT								
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date
	49	5,965,001	10-12-99	Chow et al.		204	600	
	50	6,004,441	12-21-99	Fujiwara et al.		204	412	
	51	6,103,033	8-15-00	Say et al.		156	73.1	
	52	6,134,461	10-17-00	Say et al.		600	345	
	53	6,165,594	12-26-00	Moh et al.		428	207	
	54	6,175,752 B1	1-16-01	Say et al.		600	345	
	55	6,203,952 B1	3-20-01	O'Brien et al.		430	17	
	56	6,258,229 B1	7-01	Winarta et al.		205	403	
	57	6,287,451 B1	9-11-01	Winarta et al.		205	777.5	
	58	6,299,757 B1	10-9-01	Feldman et al.		205	775	
	59	6,309,526 B1	10-30-01	Fujiwara et al.		204	403	
	60	6,338,790 B1	1-15-02	Feldman et al.		205	777.5	
	61	6,399,258 B2	6-4-02	O'Brien et al.		430	17	
	61b	6,662,439	12-16-03	Bhullar		29	825	
	62	6,696,008 B2	2-24-04	Bradinger		264	400	5-25-01
	63	US 2001/0006766 A1	7-5-01	O'Brien et al.				1-12-01
	64	US 2003/0088166 A1	5-8-2003	Say et al.				11-11-2002
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		Document Number	Date	Country		Class	Subclass	Translation Yes No
	65	0 480 703 A2	4/92	EP				--
	66	0 480 703 B1	3/97	EP				--
	67	0 875 754	11-4-98	EP				--
	68	1 152 239 A1	11-14-00	EP				--
	69	1 195 441 A1	4-10-02	EP				--
	70	1 202 060 A1	5-2-2002	EP				--
	71	1 203 956 A2/A3	5-8-2002	EP				--
	72	1 288 654 A1	03-05-03	EP				--
	74	2000-121594 abstract	April 00	JP				--
	75	56100451	Aug 81	JP				yes (abstract)
	76	11297890	Oct. 99	JP				yes (abstract)
	77	7-66499	3-10-95	JP				yes (abstract)
	78	7-290751	11-7-95	JP				yes (abstract)
	79	9-260697	10-3-97	JP				yes (abstract)
	80	10-241992 abstract	9-1-98	JP				--
	81	10-303444 abstract	11-1-98	JP				--
	83	10-275959	10-1-98	JP				yes (abstract)
	84	5-31 5703	11-26-93	JP				yes (abstract)
	85	10-52780 abstract	2-24-98	JP				--
Examiner					Date Considered			

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				APPLICANT BHULLAR et al.		FILING DATE 06/20/2003		GROUP 1743	
				FOREIGN PATENT DOCUMENTS					
86	WO 91/02391	2-21-91	PCT			--			
87	WO 91/08474	6-13-91	PCT			--			
88	WO 95/22881	8-24-95	PCT			--			
89	WO 98/35225	8-13-98	PCT			--			
90	WO 98/49773	Dec 98	PCT			--			
91	WO 99/13101	3-18-99	PCT			--			
92	WO 99/30152	6-17-99	PCT			--			
93	WO 99/45387	9-10-99	PCT			--			
94	WO 98/55856	12-10-98	PCT			--			
95	WO 00/42472 A1	7-20-00	PCT			--			
96	WO 00/73778	12/2000	PCT			--			
97	WO 00/73785	12/2000	PCT			--			
98	WO 01/36953	5-25-01	PCT			yes abstract			
99	WO 01/75438	10-11-01	PCT			--			
100	WO 01/25775	4-12-01	PCT			--			
101	WO 01/92884	12-6-01	PCT			yes abstract			
102	WO 02/086483	10-31-02	PCT			yes abstract			
103	WO 02/27074	4-4-02	PCT			yes abstract			
104	WO 02/086483	10/2002	PCT			yes abstract			
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)									
*Examiner Initial	105	Tender, L. et al., "Electrochemical Patterning of Self-Assembled Monolayers onto Microscopic Arrays of Gold Electrodes Fabricated by Laser Ablation, <i>Langmuir</i> , 1996, 12, 5515-5518.							
	106	Tahhan, Isam, "Biocompatible Microstructuring of Polymers and Electrodes with an Excimer Laser", MEDICS Workshop 2000 Speakers Abstracts, 2 pp.							
	107	Sheppard, Jr. et al. "Electrical Conductivity Measurements Using Microfabricated Interdigitated Electrodes", <i>Anal. Chem.</i> , 1993, 65, 1199-1202.							
	108	Srinivasan R., et al. "Ultraviolet Laser Ablation of Organic Polymers", <i>Chem. Rev.</i> , 1989, 89, 1303-1316.							
	109	Zongyi, Q., et al. "Excimer Laser Patterning on Thin Polymer Surfaces for Electrochemical Gas Sensors", Polymer Physics Laboratory, Changchun Institute of Applied Chemistry, Chinese Academy of Sciences, Changchun, Peop. Rep. China., Proceedings of the International Conference on Lasers (1999) 21 <sup>st</sup> (Abstract) 1pp.							
	111	Vaucher et al. "Laser Direct Imaging and Structuring: An Update", <a href="http://www.circuitree.com/CDA/ArticleInformation/features/BNP_Features_Item/0.21_33.81173.00.html">http://www.circuitree.com/CDA/ArticleInformation/features/BNP_Features_Item/0.21_33.81173.00.html</a> ; posted on: 08/01/2002.							
	112	Wu, J. et al. "Single-shot Excimer Laser Ablation of Thick Polymer Resists on Metallic Substrates", AMP Journal of Technology VOL 1 November, 1991, 69-79.							
	113	Srinivasan, R., "Ablation of Polymers and Biological Tissue by Ultraviolet Lasers", <i>Science</i> , Vol. 234, October 21, 1986, 559-564.							
	114	Colon, W., "Microanalysis: Biosensors at the Point of Care", MST News 01/04, pages 9-11.							
	115	Duley, W.W. "UV Lasers: effects and applications in materials science", Chapter 3 Photochemical and photothermal effects, Cambridge University Press, pages 78-97.							
Examiner				Date Considered					
U.S. Department of Commerce				ATTY DOCKET NO. BMID 9958 CIP US		SERIAL NO. 10/601,144			

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		FILING DATE 06/20/2003	GROUP 1743
INFORMATION DISCLOSURE STATEMENT			
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)			
	116	LPKF MicrolineLaser II, LPKF Laser & Electronics AG; LPKF; Art.-Nr. 107645-2 (01/00) (2pp.)	
	117	Microline Solutions, LPKF Laser & Electronics AG; LPKF; Art.-Nr. 107658-1 (01/00) (3pp.)	
Examiner		Date Considered	

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